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Patent PCT/JP2005/011131
Attorney Docket No. 4446

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Yoshinori Fujii)	
)	
Application No.:	10/580,946 ✓)	Verbitsky, Gail Kaplan
)	Patent Examiner
)	Art Unit 2855
Filed:	May 30, 2006)	
)	
For:	SUBSTRATE TEMPERATURE)	
	MEASUREMENT APPARATUS AND)	
	PROCESSING APPARATUS)	
)	Pittsburgh, Pennsylvania

AMENDMENT PLACING APPLICATION
IN CONDITION FOR ALLOWANCE

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This Amendment is filed in response to the Office Action dated January 2, 2009.

Kindly amend the claims as indicated hereinafter in order to place the application in condition for allowance.